



<b>INFORMATION DISCLOSURE CITATION PTO-1449</b>	Atty. Docket No. 060309	Serial No. 10/577,044
	Applicant(s): SHIGEMATSU, Ryohei	
	Filing Date: April 24, 2006	Group Art Unit: Unassigned

## **U.S. PATENT DOCUMENTS**

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					
_____	AE					

## **FOREIGN PATENT DOCUMENTS**

	Document No.	Date	Country	Translation (Yes or No)	
<u>CMA</u>	AF	2002-174794	06-21-2002	Japan	Abstract
<u>CMA</u>	AG	61-122510	06-10-1986	Japan	Abstract
<u>CMA</u>	AH	08-51522	02-20-1996	Japan	Abstract
<u>CMA</u>	AI	07-113611	05-02-1995	Japan	Abstract
<u>CMA</u>	AJ	WO 02/08818	07-23-2001	WIPO	Abstract

## **OTHER DOCUMENTS**

<u>Cindy</u>	AK	Copy of Japanese Office Action mailed January 30, 2007 received on corresponding application with partial English translation (7 pgs).
	AL	
Examiner	Khuu, Cindy	Date Considered 12-6-07

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INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 060309	Serial No. <u>New Application</u>	10/571044
	Applicant(s): Ryohei SHIGEMATSU		
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**U.S. PATENT DOCUMENTS**

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
CML	AA	2001/0036000	H. Nishikawa, et al.	11/01/01		
CML	AB	2003/0035188	J. Tominaga, et al.	02/20/03		
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**FOREIGN PATENT DOCUMENTS**

	Document No.	Date	Country	Translation (Yes or No)
CML	AE	2002-174794	06/21/02 Japan	No/Corresponds to USPP 2001/0036000
CML	AF	WO 02/08818 A1	01/31/02 PCT	Yes-Abstract/Corresponds to USPP 2003/0035188
CML	AG	8-51522	02/20/96 Japan	Yes-Abstract
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CML	AI	61-122510	06/10/86 Japan	Yes-Abstract

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CML	AJ	K. Osugi, et al.: "Development of the Scanning Laser Radar for ACC System; <i>Denso Technical Review</i> ; Vol. 6; No. 1; March 20, 2001; pp. 43-48./Discussed in the specification
	AK	
Examiner	Khuri, Cindy	Date Considered 12-5-07